

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION

OF: KIM ET AL.

SERIAL No. 09/382,708

FILED: AUGUST 24, 1999

FOR: COSMETIC COMPOSITION



MAIL STOP: RCE

CONFIRMATION No.: 5584

GROUP ART UNIT: 1617

EXAMINER: SHENGJUN WANG

Honorable Commissioner  
for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This subject Information Disclosure Statement is submitted in connection with applicants' continuing duty of disclosure under 37 C.F.R. §1.56.

LISTING OF RELEVANT DOCUMENTS:

The relevant documents are listed in the attached Form PTO-1449.

REMARKS:

The listed document (AA) was cited in the European Search Report which issued in the counterpart European application. The documents were characterized in the European Search Report as relating to the technical background of the claimed invention. The listed documents (A) and (B) are U.S. equivalents of the document (AA).

CERTIFICATION UNDER 37 C.F.R. §1.97(E):

Since this Information Disclosure Statement is submitted along with a request for continued examination, a certification under 37 C.F.R. §1.97(e) is not required.

FEE UNDER 37 C.F.R. §1.17(P):

Since this Information Disclosure Statement is submitted along with a request for continued examination, a fee under 37 C.F.R. §1.17(p) is not required (37 C.F.R. §1.97(b)).

Respectfully submitted,

KEIL & WEINKAUF



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Encl.: Form PTO-1449

HBK/BAS

Sheet: 1 of: 1

Form PTO-1449

**INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION**

(use several sheets if necessary)

DOCKET NUMBER:

**PF ++48322**

APPLICATION NUMBER:

**09/382,708**

APPLICANT:

**KIM et al.**

CONFIRMATION NUMBER:

**5548**

FILING DATE:

**August 24, 1999**

GROUP ART UNIT:

**1617****U.S. PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	US 6,132,707	10/00	DUBIEF et al.	424	78.08	09/16/96
	B	US 6,630,136	10/03	DUBIEF et al.	424	78.08	06/08/00
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						
	L						
	M						

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
	AA	WO 97/12586	04/97	WIPO	DUBIEF et al.		(A)	
	AB							
	AC							
	AD							
	AE							
	AF							

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR	DOCUMENT
	BA	
	BB	
	BC	
	BD	
	BE	
	BF	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.